



*TSW*

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application of

Docket No: Q80484

Tsukasa YAMANAKA, et al.

Appln. No.: 10/801,723

Group Art Unit: 1752

Confirmation No.: 1889

Examiner: Amanda C. Walke

Filed: March 17, 2004

For: POSITIVE RESIST COMPOSITION AND METHOD OF PATTERN FORMATION USING THE SAME

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicants hereby petition for an extension of time of one month(s), extending the time for responding to the Office Action of September 7, 2005 from December 7, 2005 to January 9, 2006 (January 7, 2006, being a Saturday).

A check for the statutory fee of \$120.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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CUSTOMER NUMBER

Date: January 9, 2006